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| Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary) | | | Complete If Known | | |
| | | | Application Number | 10/767,298-Conf.# 5002 | |
| | | | Filing Date | January 28, 2004 | |
| | | | First Named Inventor | Lingyi A. Zheng | |
| | | | Art Unit | 2824-2891 | |
| | | | Examiner Name | Michael K. Luhrs- | |
| Sheet | 1 | of | 13 | Attorney Docket Number | 108298714US |

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| Sheet | 5 | of | 13 | Attorney Docket Number | 108298714US |

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| Examiner Signature | C. Chaudhori | Date Considered | 10-05 |
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